

FEB 20 2007

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No.09/805,620
Confirmation No.3004
Filing Date March 13, 2001
Inventor..... Craig M. Carpenter
Assignee..... Micron Technology, Inc.
Group Art Unit..... 1762
Examiner Kelly M. Stouffer
Customer No.021567
Attorney's Docket No.MI22-1563
Title:..... Chemical Vapor Deposition Methods (Amended)

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Reference - See Attached Form PTO-1449

In compliance with 37 C.F.R. §§1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

This Supplemental Information Disclosure Statement is being filed together with the filing of a Request for Continued Examination (RCE) Application and before receipt of the first Office Action. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. §1.17(p) to Deposit Account No. 23-0925. Please credit Deposit Account No. 23-0925 with any overpayment of the above fee.

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: 20 Feb 2007By: James E. Lake
Reg. No. 44,854

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Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY. DOCKET NO. MI22-1563		SERIAL NO. 09/805,620	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)					APPLICANT: Craig M. Carpenter			
					FILING DATE March 13, 2001		GROUP 1762	
U.S. PATENT DOCUMENTS								
Examiner's Initials	Class	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA	6,344,151 B1	02/2002	Chen et al.				
	AB	4,444,812	04/1984	Gutsche				
	AC	5,674,574	10/1997	Abwell et al.				
	AD	4,910,043	03/1990	Freeman et al.				
	AE	4,545,327	10/1985	Campbell et al.				
	AF							
	AG							
	AH							
	AI							
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
	AJ						Yes	No
	AK							
	AL							
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
	AM							
	AN							
	AO							
	AP							
	AQ							
	AR							
EXAMINER		DATE CONSIDERED						
<small>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>								